



Docket: IB-1826A

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/656,848 Confirmation No.: 8582
Applicant : Ka-Ngo Leung, et al.
Title : NEGATIVE ION SOURCE WITH EXTERNAL RF ANTENNA
Filed : 09/06/2003
TC/A.U. : 1763
Examiner : Dhingra, Rakesh Kumar
Docket No. : IB-1826A
Cust. No. : 08076

CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION

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Name (Type/Print) Hadiyah Muhammad

Signature

Date

11/10/2005

**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22213-1450**

AMENDMENT/RESPONSE

Dear Sir:

In response to the Office Action mailed 08/10/2005, please amend the above-identified U.S. patent application as follows:

Amendments to the Specification are found on page 2 of this paper.

A Listing Of Claims begins on page 6 of this paper.

Amendments to the Abstract are found on page 9 and includes a replacement abstract.

Remarks/Arguments begin on page 10 of this paper.